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Method for the Individual Adaptation of Excitation Intensities in a Multiband
Fluorescence Microscope and a Multiband Fluorescence Microscope for Carrying Out

Said Method

- 5 The invention relates to a method for the individual adaptation of excitation intensities in a multiband fluorescence microscope and a multiband fluorescence microscope to execute the method corresponding to the features of the introductory clause of the independent claims.
- 10 With the multiband fluorescence microscope, the user frequently confronts the problem that the different fluorescence bands in the microscopic image have varying intensities and are not uniformly visible. The cause lies frequently in the difference in excitation intensities in the illumination beam path or even in the varying blockage of the fluorescence intensities by a barrier filter in the imaging beam path. Also, different
- 15 concentrations of the fluorescence die for the different excitation bands, even when staining the objects to be considered, or the progressive bleaching of the dye, the so-called fading, lead to differing intensities of the fluorescence bands in the microscopic image. The different intensities of the fluorescence bands prove to be especially problematic then if the microscopic image is to be photographically recorded. Then the
- 20 portion of the fluorescent light of weak intensity on the photo is too weakly reproduced or is not visible at all. Only with intensities of the fluorescence bands that are as uniform as possible can there be defect-free photos of the microscopic image.

- US Patent 5,371,624 specifies a fluorescence microscope having only two excitation
- 25 bands in which the intensities of the two excitation bands can be intermittently affected. It includes an illumination beam path having a light source and an excitation filter that produces several excitation bands of varying light wavelengths from the light of the light source. Furthermore, it has a splitter mirror, an output filter (also designated as a barrier

filter or emission filter) for the fluorescent light and a filter element for affecting the intensities of the excitation bands.

5 The filter element can, by tilting continuously with respect to the optical axis, be switched between two limit positions having two fixed, predetermined values of the transmission factors of one or the other excitation band. In the one limit position, only the first excitation band is attenuated, in the other limit position only the second excitation band is attenuated and between the two limit positions, neither of the excitation bands is attenuated. A drop in the transmission factor of the particular excitation band is only
10 possible up to the fixed, predetermined value. However, variation between a maximum transmission and a zero value, i.e., up to full suppression of one of the two excitation bands, is not possible. Moreover, only two excitation bands can be affected.

15 It is object of the present invention to specify a method for individual adaptation of excitation intensities in a multiband fluorescence microscope and a multiband fluorescence microscope to execute the method, in which one or more of the excitation bands can be partially or completely filtered out. For this purpose the transmission factor for each excitation band is to be continuously adjustable using simple means.

20 This objective is met by the invention via the characterizing features of the independent claims. Advantageous embodiments arise from the features of the dependent claims.

The method of the invention starts from a known multiband fluorescence microscope in which several excitation bands of varying wavelengths are produced using an excitation
25 filter in an illumination beam path from the light of a light source. The excitation bands

illuminate a fluorescence object prepared using fluorescence dyes and are converted by it into frequency-shifted fluorescence bands.

According to the invention, the fluorescence intensities of the individual fluorescence
5 bands are first determined in the microscopic image and compared to previously set intensity setpoint values. The fluorescence intensities can be determined, for example, either visually or by using an intensity meter. This can consist for example of a video or CCD camera having an image analysis system connected in an outgoing circuit.

- 10 In this context a different intensity setpoint value can be set for each fluorescence band. However, in practice, the setpoint values are oriented toward concrete problems posed by the microscope user. If, for example, the microscopic image is to be documented either photographically or by video camera, and thus each fluorescence band in the photo or in
15 the video image is to be reproduced with equal brightness, then the level of the setpoint values depends on the spectral sensitivity of the film or the camera. Therefore, their spectral sensitivity must be taken into consideration in the determination of setpoint values for the various excitation bands.

- Therefore, the desired setpoint values must all be equal – and in particular equal to the
20 lowest fluorescence intensity – provided that the film or the camera reproduces all spectral colors with equal intensity. However, if the spectral sensitivity of the video camera or of the film is not constant, then correspondingly varying setpoint values must be set for the different fluorescence bands in order to be able to reproduce the
fluorescence bands with equal brightness.

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On the other hand, if specific fluorescence bands do not appear on the photo or the video image, and thus are masked out, then the setpoint values for said bands must be equal to zero. In this context, it proves to be beneficial if the setpoint values are equal to the lowest of their intensities also for the fluorescence bands that are not masked out. Then
5 these fluorescence bands all appear equally bright.

For each excitation band that is assigned to a fluorescence intensity deviating from the setpoint values, a selective filter according to the present invention tuned to the pertinent excitation band is brought into the illumination beam path. Its spectral transmission curve
10 is configured so that exclusively the intensity of the pertinent excitation band is reduced, but the remaining spectral regions pass through unhindered.

In a multiband fluorescence microscope according to the invention for executing the method according to the invention, a filter draw assembly made of a multiplicity of
15 individually movable filter draws is perpendicularly inserted in the illumination beam path tightly next to the aperture diaphragm plane.

The structure of the filter draw is a function of the number of the different excitation bands of the multiband fluorescence microscope. For a number of n excitation bands,
20 each filter draw has n selective filters harmonized to the excitation bands and having surface regions with high and low transmission factors.

The different transmission factors are achieved by virtue of the fact that only certain area portions of the beam cross-section are occupied using separate filter-area elements. In this
25 context as even a surface coverage of the beam cross-section as possible is sought so that no unilateral shading, and thus also no unilateral illumination of the pupils, is made. As a

result a crooked illumination, and thus a lateral migration of the picture elements, is prevented during focusing.

It must be possible to insert the filters in the illumination beam path independently of each other individually or in combination using the desired surface region or the desired transmission. In this context, it must be possible with n excitation bands to combine a maximum of $n-1$ filters with each other, i.e. simultaneously insert them in the illumination beam path. This is sufficient since all excitation bands must never be attenuated simultaneously, because as a rule an excitation band supplies the intensity setpoint value and remains unchanged. Likewise, all excitation bands must not be triggered simultaneously, since this is equivalent to turning off the lighting.

In order to achieve the required combinations from $n-1$ filters, $n-1$ individually movable filter draws that are situated tightly parallel next to the aperture diaphragm plane with little distance between them and are effectual in combination are arranged in an advantageous embodiment of a multiband fluorescence microscope according to the invention having n excitation bands on $n-1$ disk planes. With each filter draw, one filter for an excitation band can be suitably adjusted so that altogether a maximum of $n-1$ excitation bands (one less than the maximum number) can be selectively attenuated or triggered.

For two excitation bands, it is sufficient if the two required filters are arranged in a single disk plane ($n-1=1$), since either only the one or only the other filter must be inserted in the illumination beam path. Therefore, a filter draw assembly to affect two excitation bands is preferably of one piece, thus designed with only one filter draw. However, for

more than two excitation bands, a corresponding multi-piece filter draw assembly must be provided with $n-1$ individually movable filter draws.

Except for the selective filters for the various excitation bands, each filter draw has at least one blank aperture with the beam diameter of the illumination beam path. In this case a blank aperture is arranged next to each filter. Depending on the embodiment, the filters can also be grouped directly around a single blank aperture. The transmission factor of the filter diminishes in the shifting direction as the distance from the blank aperture increases. In this case each filter has a surface region with the lowest transmission factor and a minimum diameter equal to the beam diameter x . If this surface region is inserted in the illumination beam path, the associated excitation band is maximally attenuated, i.e., to the zero value.

By correctly positioning each of the individual filters in the illumination beam path, the transmission factor that is acting on the illumination beam path is precisely individually adjusted such that by attenuating the excitation band assigned to the filter, the resulting fluorescence intensity matches its intensity setpoint value. To execute this process step, separate positioning means, which bring about the full or partial covering of the illumination beam path using the appropriate surface region of the filter draw, are assigned to each filter draw. Thus, the blank aperture or one or more of the filters or combinations of filter regions and the blank aperture can be inserted in the illumination beam path, according to preference. If this last process step was executed for all filters and thus all excitation bands, all fluorescence intensities match their setpoint values.

Even after optimal setting of the fluorescence intensities by applying the method according to the invention using a specified multiband fluorescence microscope,

deviations of the fluorescence intensities from the setpoint values reoccur after some time. This is attributable to the fact that the various fluorescence dyes for the various excitation bands fade at differing rates, i.e., they exhibit a specific fading.

5 Therefore, in one advantageous embodiment of the method, the time changes of the fluorescence intensities are continuously determined. The transmission factors of the filter that are in effect within the illumination beam path are then repeatedly adjusted at specific time intervals so that the fluorescence intensities are always brought into accord with their setpoint values.

10 An especially advantageous embodiment of the method provides for an automatic fading compensation. For this purpose the time modifications of the fluorescence intensities are automatically continually determined. To do this the microscopic image, for example, can be automatically continually recorded using a video camera and the fluorescence
15 intensities contained therein can be determined using an image analysis system and compared to the predetermined setpoint values.

Then the transmission factors of the filter are automatically continuously modified and adapted so that the fluorescence intensities are always kept at the intensity setpoint
20 values. To this end, motorized positioning means, for example, can be used. The drive of the motors and regulation of the fluorescence intensities in relation to the setpoint values can be achieved using an electronic unit and a computer to which the signals of the video camera or the image analysis system are fed.

25 The invention is explained in more detail below with respect to the schematic drawing.
Shown are:

Figure 1 a beam path of a multiband fluorescence microscope according to the invention;

5 Figure 2a-d various embodiments of a filter draw for a dual-band fluorescence microscope;

Figure 2e the spectral transmission curve of the excitation bands and the assigned filter of a filter draw for a dual-band fluorescence microscope;

10 Figure 3a-c various embodiments of a filter draw for a two-piece filter draw assembly of a three-band fluorescence microscope;

15 Figure 3d the spectral transmission curve of the excitation bands and the assigned filter of a filter draw for a three-band fluorescence microscope;

Figure 4a-b various embodiments of a filter draw for a three-part filter draw assembly of a four-band fluorescence microscope;

20 Figure 4c the spectral transmission curve of the excitation bands and the assigned filter of a filter draw for a four-band fluorescence microscope.

Figure 1 shows a beam path of a multiband fluorescence microscope for executing the method according to the invention. From a light source 1 an illumination beam path starts
25 with an optical axis 2 in which a collector 3, a first lens member 4, an aperture diaphragm 5, a second lens member 6, a radiant field stop 7, a third lens member 8 and a excitation

filter 9 are arranged in succession to produce the excitation bands. The illumination beam path is deflected at a beam splitter 10 to an objective 11. It passes through the objective 11 and reaches a fluorescence object 12, which rests on a specimen stage 13.

- 5 The excitation bands produced by excitation filter 9 in the illumination beam path are converted into fluorescence bands 12 by fluorescence dyes that were injected in fluorescence object 12, and said bands are emitted by the fluorescence object in a frequency-shifted state. This fluorescence light passes through objective 11, beam splitter 10, an output filter 14, a tube lens 15 and reaches an intermediate image plane 16. The
10 intermediate image produced here can be considered by microscope user using an eyepiece 17. The intermediate image is displayed via a TV output on a video camera 18 having an image analysis system 19 connected in series. With this design the fluorescence intensities of the individual fluorescence bands in the microscopic image can be determined either visually using eyepiece 17 or using image analysis system 19 and then
15 compared to intensity setpoint values greater than or equal to zero.

- To attenuate the excitation bands, a filter draw assembly 20 according to the invention, consisting in this example of two filter draws 21a and 21b, is inserted perpendicular to the optical axis 2 of the illumination beam path tightly next to, i.e., behind or in front of
20 aperture diaphragm plane 24. Arranged on each filter draw 21a, 21b are a blank aperture 22 and in addition several selective filters 23 tuned to the excitation bands. By arranging filter draws 21a, 21b as narrowly as possible, filters 23 can be situated as tightly as possible next to aperture diaphragm plane 24. This ensures that the inserted filter draws 21a, 21b are not visible in the image. A further advantage is that in this case the least
25 possible beam fanning occurs, so that the surface region of filter 23 can be kept as small as possible.

According to the present invention, positioning means are assigned to each filter draw. In this context positioning means having the possibility of manual adjustability can be used in economic embodiments. Although motorized positioning means are more expensive, they permit an automation of the method according to the invention.

In the embodiment illustrated here, two motors 25a, 25b that can shift parallel to the aperture diaphragm plane and/or rotate filter draws 21a, 21b are arranged as positioning means for filter draws 21a, 21b. Using the motors 25a, 25b either the blank aperture 22 or a selective filter 23 or a combination of the two can be inserted in the illumination beam path by the particular assigned filter draw 21a or 21b. The motors 25a, 25b are driven by control electronics 26, which receive the input signal from the image analysis system 19.

The image analysis system 19 determines from the camera signal the deviation of the fluorescence intensities from their setpoint values. Then those excitation bands that cause the deviations from setpoint values are determined and one of the filter draws 21a, 21b is assigned to each of these excitation bands for attenuation. In the illustrated example, two excitation bands can thus be completely attenuated, i.e. to the zero value, or even partially attenuated. For each filter draw 21a, 21b a drive signal is produced for the associated motor 25a, 25b. Each filter draw 21a, 21b is continuously shifted via the associated motor 25a, 25b so that a filter 23 selectively acting on the assigned excitation band is inserted in the illumination beam path. Then the filter draw 21a or 21b is shifted further until a surface region of the inserted filter 23 has a transmission factor in the illumination beam path through which the assigned excitation band is attenuated to the intensity setpoint value. In this way, all excitation bands are set to their intensity setpoint values.

Different embodiments of filter draw assembly 20 or the filter draw 21 and the associated spectral transmission curves of the filters arranged on them are explained below.

5 A filter draw 21 for a multiband fluorescence microscope having two excitation bands A and D is depicted in Figure 2a. Applied to a rectangular glass plate 27 as different vapor deposition layers are a long-pass filter 29 for the intensity reduction of the short-wave excitation band A and a short-pass filter 28 for the intensity reduction of the long-wave excitation band D. They are located on the ends of the glass plate 27, and between them is the blank aperture 22 in the center of filter draw 21. Its cross-section is equal to the beam
10 diameter x in the aperture diaphragm 5 of the illumination beam path. Filter draw 21 can be continuously shifted by positioning means (not shown) longitudinally in both directions parallel to the aperture diaphragm plane 24. The movement is indicated by a double arrow.

15 Short-pass filter 28 and long-pass filter 29 are each applied in this version as a connected vapor-deposition layer. The transmission of the two filters 28, 29 is largest right next to blank aperture 22 and gets smaller as the distance from blank aperture 22 increases. To this end next to blank aperture 22 filter draw 21 is not completely covered with filters 28, 29, but rather the portion of the filter area increases as one moves from blank aperture 22
20 toward the end of filter draw 21.

Thus, the vapor-deposition layers on the ends of filter draw 21 form a rectangle with a minimum edge length equal to the beam diameter x . If this vapor-deposited rectangular area completely covers the illumination beam path, the smallest percentile is thus set and
25 the accompanying excitation band is completely attenuated, i.e., to the zero value. The

vapor-deposited rectangular area borders the base of vapor-deposited triangular area, whose opposing corner faces blank aperture 22.

5 Via the vapor-deposited triangular areas, which always cover the beam diameter only partially, the transmission factor of short-pass filter 28 and long-pass filter 29 in each case diminishes as one moves from blank aperture 22 toward the ends of filter draw 21. By inserting any fractional area of short-pass filter 28 or of long-pass filter 29, any desired transmission factor of the filter 28, 29 in the illumination beam path can be realized and thus one or the other excitation band can be weakened or faded out according to preference.

10 A filter draw 21 for a multiband fluorescence microscope according to the invention having two excitation bands A and D is likewise depicted in Figure 2b. Applied to a rectangular glass plate 27 are a short-pass filter 28 for filtering the long-wave excitation band A and a long-pass filter 29 for filtering the short-wave excitation band D as different vapor-deposition layers.

20 Here, as in Figure 2a, the vapor-deposition layers in the direction of blank aperture 22 have a triangular contour. However, the triangles in this case are each not vapor-deposited as connected areas, but rather as small area elements 30 of equal size. In this way a longer adjustment range with higher transmissions is achieved for the two filters 28, 29. At the ends of filter draw 21, the vapor-deposition layers form a rectangle having a minimum edge length equal to the beam diameter x and thus a region of the least transmission with which the assigned excitation band can be attenuated to zero.

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Another filter draw 21 for a multiband fluorescence microscope according to the invention having two excitation bands A and D is depicted in Figure 2c. Applied to a rectangular glass plate 27 are a short-pass filter 28 for filtering the long-wave excitation band A and a long-pass filter 29 for filtering the short-wave excitation band D as different vapor-deposition layers. Located between them is a blank aperture 22.

The filters 28, 29 are vapor-deposited in this version of filter draw 21 next to blank aperture 22 as separate area elements 30 formed in any way desired (here circular).

10 In this context, the size of area elements 30 and thus the portion of the area of filter draw 21 increases when moving from blank aperture 22 to the ends of filter draw 21. The transmission factor of filters 28, 29 is largest next to blank aperture 22 and diminishes when moving in the direction toward the ends of filter draw 21. On both ends of filter draw 21, each of the two filters 28, 29 have a completely vapor-deposited area with the
15 smallest transmission factor, said area having at least the diameter x of the beam path.

Another filter draw 21 for a multiband fluorescence microscope according to the invention having two excitation bands A and D is depicted in Figure 2d. Applied to a rectangular glass plate 27 are a short-pass filter 28 for filtering the long-wave excitation
20 band A and a long-pass filter 29 for filtering the short-wave excitation band D as different vapor-deposition layers. Located between them is a blank aperture 22.

In this embodiment the vapor-deposition layers are applied as strip-shaped area elements 30, the width of the strips increasing as one moves from the center to the ends of filter
25 draw 21. In this way the transmission diminishes as one moves from the blank aperture 22 toward the ends of filter draw 21. Also here the two filters 28, 29 each have a

completely vapor-deposited surface with the lowest possible transmission factor at both ends of filter draw 21, said surface having at least the diameter x of the beam path.

5 The spectral transmission curves of the short-wave excitation band A and the long-wave excitation band D, as well as the transmission curves T_A , T_D of the associated selective filter, thus the long-pass filter for the short-wave excitation band A and the short-pass filter for the long-wave excitation band D, are depicted in Figure 2e as a function of the light wavelength λ . Filters A and B are selected so that they only selectively filter out the associated excitation band for each but allow the remaining wavelength ranges to pass
10 through unhindered.

Figure 3a shows a rectangular filter draw 21 of a two-piece filter draw assembly 20 for a multiband fluorescence microscope having three excitation bands A, B, D. In this embodiment filter draw assembly 20 consists of two rectangular filter draws 21 identical
15 to said bands that are tightly inserted in the illumination beam path one behind the other next to the aperture diaphragm plane 24.

Provided in the center of filter draw 21 is the blank aperture 22 having diameter x of illumination beam path 2. Applied as vapor-deposition layers on the two ends of filter
20 draw 21 are two different combinations of two or three selective filters 28, 29, 31 for excitation bands A, B, D. The two filters 28, 31 or 29, 31 on one end are in each case arranged next to one another so that both filters border each other and blank aperture 22. In this context each filter 28, 29, 31 has an area of least transmission having at least the diameter x of illumination beam path 2. As a result filter draw 21 has at least a width of
25 $2x$ on its short end.

5 The transmission factor of filters 28, 29, 31 diminishes as one moves in the longitudinal direction of filter draw 21, thus in the direction of shift from blank aperture 22 toward the ends. This is realized in the example represented here in that the vapor-deposited surface of each filter 28, 29, 31 increases as one moves from blank aperture 22 toward the end of filter draw 21.

10 Separate positioning means 25 for shifting filter draw 21 parallel to aperture diaphragm plane 24 in both the longitudinal and transverse directions are provided for each of the two identical shifters 21 of the filter draw assembly. As a result it is possible to insert filters 28, 29, 31, individually or in combination, completely or with only a portion of their surface in the illumination beam path.

15 Figure 3b shows a circular filter draw 21 of a two-piece filter draw assembly 20 for a multiband fluorescence microscope according to the invention having three excitation bands A, B, D. In this advantageous embodiment of the multiband fluorescence microscope according to the invention, filter draw assembly 20 consists of two circular filter draws 21 identical to said bands that are tightly inserted in the illumination beam path one behind the other next to the aperture diaphragm plane 24. Provided in the center of each filter draw 21 is blank aperture 22. Three selective filters 28, 29, 31 for excitation
20 bands A, B, D are arranged bordering said opening as vapor-deposited ring sectors that border each other.

25 Filters 28, 29, 31 each possess a transmission factor that decreases as radius increases and is largest next to blank aperture 22. This is accomplished, for example, by virtue of filters 28, 29, 31 not being fully vapor-deposited. Instead, vapor-deposited area elements 30 that get wider as they extend radially and that have non-vapor-deposited surface regions are

applied in between them next to blank aperture 22 so that the portion of vapor-deposited surface of each filter 28, 29, 31 increases as the radius increases.

Using separate positioning means (not shown here), each of the two identical filter draws 21 of filter draw assembly 20 can be shifted individually and parallel to aperture diaphragm plane 24. In this case it can either be laterally shifted in one direction and also rotated (as indicated in Figure 3b) or, alternatively, shifted within a plane in two directions. As a result any desired fractional area of filter draw 21, for example blank aperture 22 or one of the filters 28, 29, 31 having the desired transmission factor, can be inserted in the illumination beam path. By arranging two equal filter draws 21 in the illumination beam path, any two of the three filters 28, 29, 31 can be inserted simultaneously in the illumination beam path so that two of the three excitation bands can be simultaneously weakened to the predetermined setpoint values or completely faded out.

Figure 3c shows an especially advantageous embodiment of a filter draw 21 for a two-piece filter draw assembly 20 of a multiband fluorescence microscope according to the invention having three excitation bands A, B, D. In this embodiment of the multiband fluorescence microscope, filter draw assembly 20 consists of two circular filter draws 21 identical to said bands that are inserted in the illumination beam path tightly in succession next to aperture diaphragm plane 24.

The filters 28, 29, 31 for the excitation bands A, B, D are advantageously arranged on the filter draw 21 such that it only has to be turned but not shifted (rotary movement is indicated). This simplifies the structure of the mechanical or even motorized positioning means, which are separately assigned to each of the two filter draws 21 (not shown).

In order to accomplish this, each filter draw 21 is designed with a circular shape, divided into six sectors and arranged pivoted around its center. The center of the circle lies outside the illumination beam path. Each sector can be turned by rotating filter draw 21 into the illumination beam path and cover it completely. The beam cross section with the diameter x is inscribed.

Each second sector is a blank aperture 22. Applied, for example glued on or vapor-deposited, in between each is one of the three filters 28, 29, 31 for the three excitation bands A, B, D. Each filter 28, 29, 31 exhibits an increase of the transmission factor inside its sector in one of the two directions of rotation, for example via different surface coverage with vapor-deposited area elements. As a result each filter 28, 29, 31 has next to the one neighboring blank aperture 22 a maximum transmission factor and next to the other neighboring blank aperture 22 a minimum transmission factor. By rotating the filter draw 21, one of the blank apertures 22 or one of the filters 28, 29, 31 with the desired transmission or a combination of the two can be inserted in the illumination beam path. The use of two identical filter draws 21 as a filter draw assembly makes it possible to attenuate up to two of the three excitations bands A, B, D simultaneously and independently of each other to the desired setpoint value.

Figure 3d shows the spectral transmission curves of the short-wave excitation band A, of the long-wave excitation band D and an intermediate excitation band B as a function of the light wavelength λ .

Furthermore, the transmission curves T_A , T_B , T_D of the accompanying selective filters are depicted, thus the long-pass filter for the short-wave excitation band A, of the short-pass

filter for the long-wave excitation band D and a selective filter for the excitation band B. The filters are selected so that they only selectively filter out the associated excitation band, but the remaining wavelength ranges pass through unhindered.

- 5 Figure 4a shows a circular filter draw 21 for a three-part filter draw assembly 20 of a multiband fluorescence microscope according to the invention having four excitation bands A, B, C, D. In this embodiment of the multiband fluorescence microscope according to the invention, filter draw assembly 20 consists of three circular filter draws identical to said bands that are tightly inserted in the illumination beam path one behind
10 the other next to the aperture diaphragm plane 24. Each filter draw 21 has a blank aperture 22 in the center. In addition four selective filters 28, 29, 31, 32 for the excitation bands A, B, C, D, are vapor deposited as ring sectors that border each other.

- The transmission factor of the filters 28, 29, 31, 32 diminishes as the radius increases and
15 is largest next to the blank aperture 22. This is achieved, for example, by vapor-depositing the filters 28, 29, 31, 32 not completely, but as ring-shaped area elements 30 with non-vapor-deposited areas with vapor-deposition between them, whereby the portion of the vapor-deposited area of each filter 28, 29, 31, 32 increases as the radius increases.

- 20 Separate positioning means (not shown) are assigned to each of the three filter draws 21 of filter draw assembly 20. Using these positioning means, each filter draw 21 can be moved individually and parallel to aperture diaphragm plane 24. In this case it can be shifted laterally in one direction and also rotated (as indicated in Figure 4a) or alternatively shifted in two directions within one plane.

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As a result, any fractional area of filter draw 21, thus the blank aperture 22 or any fractional area filters 28, 29, 31, 32, can be inserted in the illumination beam path. By arranging three equal filter draws 21 in the illumination beam path, any three of the four filters 28, 29, 31, 32 can be simultaneously inserted in the illumination beam path. As a result up to three of the four excitation bands A, B, C, D can be weakened to the predetermined setpoint value or even faded out completely.

Figure 4b shows an especially advantageous embodiment of a filter draw 21 for a three-part filter draw assembly 20 for a multiband fluorescence microscope according to the invention having four excitation bands A, B, C, D. In this embodiment of the multiband fluorescence microscope according to the invention, filter draw assembly 20 consists of three circular filter draws 21 identical to said bands and are inserted in the illumination beam path tightly in succession next to aperture diaphragm plane 24.

The filters 28, 29, 31, 32 for the excitation bands A, B, C, D are arranged on the filter draw 21 such that it only has to be rotated, but does not have to be moved (rotating movement is indicated). That simplifies the design of the mechanical or even motorized positioning means that are separately assigned to each of the three filter draws 21 (not shown).

This is achieved by virtue of each filter draw 21 being designed with a circular shape, divided into eight sectors and mounted pivoted around its center. The center of the circle is outside the illumination beam path. By rotating the filter draw 21, each sector can be brought to totally or partially cover the illumination beam path. The beam cross section with the diameter x is inscribed.

Every second sector is a blank aperture 22. In between them one of the four filters 28, 29, 31, 32 is applied, e.g., glued or vapor-deposited, for the three [sic] excitation bands A, B, C, D. Each filter 28, 29, 31, 32 exhibits an increase of the transmission factor inside its sector in one of the two directions of rotation, for example, via different area coverage.

- 5 As a result each filter 28, 29, 31, 32 has a maximum transmission factor next to the one neighboring blank aperture 22 and a minimum transmission factor next to the other neighboring blank aperture 22.

- 10 By rotating filter draw 21, one of blank apertures 22 or one of filters 28, 29, 31, 32 having the desired transmission of a combination of both can be inserted in the illumination beam path. By using three filter draws 21, up to three of the four excitation bands A, B, C, D can be attenuated to the desired setpoint value simultaneously and independently of one another.

- 15 In Figure 4c, the spectral transmission curves of the short-wave excitation band A, of the long-wave excitation wave excitation band D and of the two excitation bands B and C between them are represented as a function of the light wavelength λ . Furthermore, the transmission curves T_A , T_B , T_C , T_D are specified for the associated selective filter, thus the long-pass filter for the short-wave excitation band A, the short-pass filter for the long-wave excitation band D, a selective filter for the excitation band B and a selective filter
- 20 for the excitation band C. Filters A, B, C, D are selected so that they only selectively filter out the particular associated excitation band, but the remaining wavelength ranges pass through unhindered.

For more than four excitation bands, the filter draw assembly 20 must be expanded accordingly. However, it is becoming increasingly difficult to place the individual filters close enough next to aperture diaphragm 5.

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1970-1971 1971-1972 1972-1973 1973-1974 1974-1975 1975-1976 1976-1977 1977-1978 1978-1979 1979-1980 1980-1981 1981-1982 1982-1983 1983-1984 1984-1985 1985-1986 1986-1987 1987-1988 1988-1989 1989-1990 1990-1991 1991-1992 1992-1993 1993-1994 1994-1995 1995-1996 1996-1997 1997-1998 1998-1999 1999-2000 2000-2001 2001-2002 2002-2003 2003-2004 2004-2005 2005-2006 2006-2007 2007-2008 2008-2009 2009-2010 2010-2011 2011-2012 2012-2013 2013-2014 2014-2015 2015-2016 2016-2017 2017-2018 2018-2019 2019-2020 2020-2021 2021-2022 2022-2023 2023-2024 2024-2025 2025-2026 2026-2027 2027-2028 2028-2029 2029-2030 2030-2031 2031-2032 2032-2033 2033-2034 2034-2035 2035-2036 2036-2037 2037-2038 2038-2039 2039-2040 2040-2041 2041-2042 2042-2043 2043-2044 2044-2045 2045-2046 2046-2047 2047-2048 2048-2049 2049-2050 2050-2051 2051-2052 2052-2053 2053-2054 2054-2055 2055-2056 2056-2057 2057-2058 2058-2059 2059-2060 2060-2061 2061-2062 2062-2063 2063-2064 2064-2065 2065-2066 2066-2067 2067-2068 2068-2069 2069-2070 2070-2071 2071-2072 2072-2073 2073-2074 2074-2075 2075-2076 2076-2077 2077-2078 2078-2079 2079-2080 2080-2081 2081-2082 2082-2083 2083-2084 2084-2085 2085-2086 2086-2087 2087-2088 2088-2089 2089-2090 2090-2091 2091-2092 2092-2093 2093-2094 2094-2095 2095-2096 2096-2097 2097-2098 2098-2099 2099-2100 2100-2101 2101-2102 2102-2103 2103-2104 2104-2105 2105-2106 2106-2107 2107-2108 2108-2109 2109-2110 2110-2111 2111-2112 2112-2113 2113-2114 2114-2115 2115-2116 2116-2117 2117-2118 2118-2119 2119-2120 2120-2121 2121-2122 2122-2123 2123-2124 2124-2125 2125-2126 2126-2127 2127-2128 2128-2129 2129-2130 2130-2131 2131-2132 2132-2133 2133-2134 2134-2135 2135-2136 2136-2137 2137-2138 2138-2139 2139-2140 2140-2141 2141-2142 2142-2143 2143-2144 2144-2145 2145-2146 2146-2147 2147-2148 2148-2149 2149-2150 2150-2151 2151-2152 2152-2153 2153-2154 2154-2155 2155-2156 2156-2157 2157-2158 2158-2159 2159-2160 2160-2161 2161-2162 2162-2163 2163-2164 2164-2165 2165-2166 2166-2167 2167-2168 2168-2169 2169-2170 2170-2171 2171-2172 2172-2173 2173-2174 2174-2175 2175-2176 2176-2177 2177-2178 2178-2179 2179-2180 2180-2181 2181-2182 2182-2183 2183-2184 2184-2185 2185-2186 2186-2187 2187-2188 2188-2189 2189-2190 2190-2191 2191-2192 2192-2193 2193-2194 2194-2195 2195-2196 2196-2197 2197-2198 2198-2199 2199-2200 2200-2201 2201-2202 2202-2203 2203-2204 2204-2205 2205-2206 2206-2207 2207-2208 2208-2209 2209-2210 2210-2211 2211-2212 2212-2213 2213-2214 2214-2215 2215-2216 2216-2217 2217-2218 2218-2219 2219-2220 2220-2221 2221-2222 2222-2223 2223-2224 2224-2225 2225-2226 2226-2227 2227-2228 2228-2229 2229-2230 2230-2231 2231-2232 2232-2233 2233-2234 2234-2235 2235-2236 2236-2237 2237-2238 2238-2239 2239-2240 2240-2241 2241-2242 2242-2243 2243-2244 2244-2245 2245-2246 2246-2247 2247-2248 2248-2249 2249-2250 2250-2251 2251-2252 2252-2253 2253-2254 2254-2255 2255-2256 2256-2257 2257-2258 2258-2259 2259-2260 2260-2261 2261-2262 2262-2263 2263-2264 2264-2265 2265-2266 2266-2267 2267-2268 2268-2269 2269-2270 2270-2271 2271-2272 2272-2273 2273-2274 2274-2275 2275-2276 2276-2277 2277-2278 2278-2279 2279-2280 2280-2281 2281-2282 2282-2283 2283-2284 2284-2285 2285-2286 2286-2287 2287-2288 2288-2289 2289-2290 2290-2291 2291-2292 2292-2293 2293-2294 2294-2295 2295-2296 2296-2297 2297-2298 2298-2299 2299-2300 2300-2301 2301-2302 2302-2303 2303-2304 2304-2305 2305-2306 2306-2307 2307-2308 2308-2309 2309-2310 2310-2311 2311-2312 2312-2313 2313-2314 2314-2315 2315-2316 2316-2317 2317-2318 2318-2319 2319-2320 2320-2321 2321-2322 2322-2323 2323-2324 2324-2325 2325-2326 2326-2327 2327-2328 2328-2329 2329-2330 2330-2331 2331-2332 2332-2333 2333-2334 2334-2335 2335-2336 2336-2337 2337-2338 2338-2339 2339-2340 2340-2341 2341-2342 2342-2343 2343-2344 2344-2345 2345-2346 2346-2347 2347-2348 2348-2349 2349-2350 2350-2351 2351-2352 2352-2353 2353-2354 2354-2355 2355-2356 2356-2357 2357-2358 2358-2359 2359-2360 2360-2361 2361-2362 2362-2363 2363-2364 2364-2365 2365-2366 2366-2367 2367-2368 2368-2369 2369-2370 2370-2371 2371-2372 2372-2373 2373-2374 2374-2375 2375-2376 2376-2377 2377-2378 2378-2379 2379

Reference symbol list

- 1 Light source
- 2 Optical axis of the illumination beam path
- 5 3 Collector
- 4 First lens member
- 5 Aperture diaphragm
- 6 Second lens member
- 7 Radiant field stop
- 10 8 Third lens member
- 9 Excitation filter
- 10 Beam splitter
- 11 Objective
- 12 Fluorescence object
- 15 13 Specimen stage
- 14 Output filter
- 15 Tube lens
- 16 Intermediate image plane
- 17 Eyepiece on tube (17')
- 20 18 Video camera
- 19 Image analysis system
- 20 Filter draw assembly
- 21 Filter draw (also 21a, 21b)
- 22 Blank aperture
- 25 23 Selective filter(s)
- 24 Aperture diaphragm plane

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